



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: In-Hak Park, et al.

Serial No. 10/027,641 Examiner: Pham, Hoa Q

Confirmation No. 1483

Filed: December 19, 2001 Group Art Unit: 2877

For: SEMICONDUCTOR WAFER POSITION DETECTING SYSTEM,
SEMICONDUCTOR DEVICE FABRICATING FACILITY OF
USING THE SAME, AND WAFER POSITION DETECTING
METHOD THEREOF

Mail Stop NON FEE AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Responsive to the Office Action dated June 19, 2003, enclosed is an amendment in the above-identified application.

The fee has been calculated as shown below.

CLAIMS AS AMENDED					
For:	Number After Amendment	Previous Number	Extra	Rate	Additional Fee
Total Claims	18	18-20	0	x \$18 =	\$0.00
Independent Claims	3	3-3	0	x \$84 =	\$0.00
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT					\$0.00

*greater of twenty (20) or number for which fee has been paid

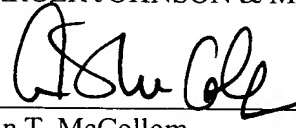
**greater of three (3) or number for which fee has been paid

- ☒ TWO sheets drawings, one annotated and one replacement.
☒ Any deficiency or overpayment should be charged or credited to deposit account number 13-1703.

Customer No. 20575

Respectfully submitted,

MARGER JOHNSON & McCOLLOM, P.C.


Alan T. McCollom
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Date: September 15, 2003


Adrienne Chochoiak



PATENT APPLICATION
Docket No. 5484-089
Client No. PX1333-US/SSM

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MAIL STOP NON FEE AMENDMENT

Commissioner for Patents

P.O. Box 1450

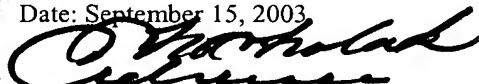
Alexandria, VA 22313-1450

AMENDMENT

Responsive to the Office Action, Paper No. 3, dated June 19, 2003, please amend the application as follows.

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Date: September 15, 2003


Adrienne Chocholak

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